



10/27/2005 14:53 207-862-4681

FASSE PATENT ATTYS

PAGE 01/02

1FW

Receipt

BY TELEFAX 703-746-9195

DOCKET NO.: 4887

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF THE APPLICATION FOR PATENT

OF: Makoto OTSUKI et al.

| ART UNIT: 2812

SERIAL NO.: 10/537,529

| CONF. NO.: 4558

FILED: June 3, 2005

FOR: METHOD OF MANUFACTURING SINGLE-CRYSTAL SEMICONDUCTOR WAFERS  
AND LASER MACHINING APPARATUS THEREFOR

MAIL STOP MISSING PARTS  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

October 27, 2005

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Dear Sir:

- 1) The Official Filing Receipt contains errors. Please correct the following items as shown on the enclosed marked-up copy of the Filing Receipt:

- Assignment for Published Patent Application
- Title

- 2) The requested corrections are supported by the application transmittal letter and the specification as filed on June 3, 2005.  
*(see the bottom of page 1 thereof)*

- 3) Please issue a corrected Filing Receipt.

Respectfully submitted,  
Makoto OTSUKI et al.-Applicant

WFF:ks/4887

Enclosure:  
Hand-corrected  
copy of OFR

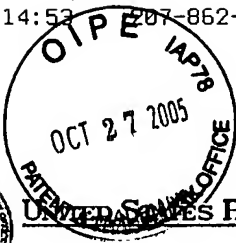
By

*Walter Fasse*  
W. F. Fasse - Patent Attorney  
Reg. No.: 36132  
Tel: 207 862 4671  
Fax: 207 862 4681  
P.O. Box 726, Hampden, ME 04444-0726

CERTIFICATE OF FAX TRANSMISSION:

I hereby certify that this correspondence with all indicated enclosures is being transmitted by telefax to 703-746-9195 on the date indicated below, and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

*Karin Smith - October 27, 2005*  
Name: Karin Smith - Date: October 27, 2005



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE RECD	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/537,529	06/03/2005	2812	1900	4887/PCT	5	40	2

CONFIRMATION NO. 4558

21553  
 FASSE PATENT ATTORNEYS, P.A.  
 P.O. BOX 726  
 HAMPDEN, ME 04444-0726

RECEIVED

OCT 13 2005

FILING RECEIPT



\*OC000000017118694\*

FASSE PATENT ATTORNEYS

Date Mailed: 10/03/2005

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Makoto Otsuki, Itami-shi, JAPAN;  
 Masayuki Nishikawa, Itami-shi, JAPAN;  
 Yasuyuki Matsui, Itami-shi, JAPAN;

**X** Assignment for Published Patent Application  
 Sumitomo Electric Industries, Ltd., Osaka-shi, JAPAN **X**

Power of Attorney: The patent practitioners associated with Customer Number 21553.

## Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/08108 06/10/2004

## Foreign Applications

JAPAN 2003-176746 06/20/2003

Projected Publication Date: 01/05/2006

Non-Publication Request: No

Early Publication Request: No

**X** Title

Method of manufacturing single-crystal semiconductor wafers  
~~Method of producing semiconductor single crystal wafer and laser processing device used therefor~~  
 and laser machining apparatus therefor **X**